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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM FILING DATE CLASS SUBCLASS GAU EXAMINER
10073593 02/12/2002 356 500 2877 *Forney Lyons*

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**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2001-038230 02/15/2001

JAPAN 2002-02332 02/05/2002

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no
ATTORNEY DOCKET NO 00862.022516		
TITLE : Exposure apparatus including interferometer system		
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
Assistant Examiner		Total Claims	Print Claim for 0.0
Amount Due	Date Paid	DRAWING	Print Fig.
Primary Examiner		Cheets Drawn	PC Drawn
PREPARED FOR ISSUE		Application Ent. minor	
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(Attached to patent on 10/17/02 (page 10))